



Serial No. 09/851,089  
SEC.837  
Amendment dated 29 August 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re PATENT APPLICATION of:

Jong-Woon OH et al.

Group Art Unit: 1744

Serial No.: 09/851,089

Examiner: Laura C. COLE

Filed: 9 May 2001

CLEANING APPARATUS FOR  
SEMICONDUCTOR WAFER

5/A  
JL  
9/11/03  
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SEP 05 2003  
GROUP 1700

**AMENDMENT**

U.S. Patent and Trademark Office  
2011 South Clark Place  
Customer Window, Mail Stop Fee Amendment  
Crystal Plaza Two, Lobby, Room 1B03  
Arlington, VA 22202

Sir:

In response to the Office Action dated 20 May 2003, the period for response to which is hereby being extended by the accompanying Petition and Petition Fee to 20 September 2003, please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.